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CONFIRMATION NO. 5406

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SERIAL NUMBER 10/665,122	FILING DATE 09/22/2003	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 2557-000163/US
	RULE			

## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

*Name WLC*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2002-57456 09/19/2002 *WLC*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 12/11/2003

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	<i>WLC</i>	Initials	DRAWING 7	CLAIMS 25	CLAIMS 2

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## TITLE

Methods of fabricating a semiconductor device having a metal gate pattern

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )